

GAU/1765
#8/B
2/1/02



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re of Applicant)
Hirohisa KIKUYAMA et al.) Art Group: 1765
Serial No.: 09/622,397)
Filing Date: December 1, 2000)
Title: SURFACE TREATING FOR) Examiner: Kin Chan CHEN
MICROMACHINING AND METHOD)
FOR SURFACE TREATMENT)

RESPONSE

Hon. Commissioner of Patents
Washington, D.C. 20231

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Sir:

Responsive to the Office Action dated December 19, 2001,
having a due date of January 19, 2002, Applicant hereby submits
the following election.

REMARKS

Claims 1-19 are pending and subject to election in the
present application.

With this response, Applicant elects Group I, Claims 1-4 and
9, drawn to a composition for etching and cleaning without
5 traverse. Please cancel Claims 5-8 and 10-19 without prejudice.